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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10072339	FILING DATE 02/07/2002	CLASS 368 306-1	SUBCLASS 2832	GAU 2832	EXAMINER Nguyen Hg
**APPLICANTS: Wu Bing-Chang;					
**CONTINUING DATA VERIFIED: <i>NY</i> THIS APPLICATION IS A DIV OF 09/653,108 08/31/2000 <i>yes</i>					
** FOREIGN APPLICATIONS VERIFIED: <i>NY</i> TAIWAN 89116610 08/17/2000 <i>yes</i>					
PG-PUB <input type="checkbox"/>		DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>	
Foreign priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials <i>WBC</i>			ATTORNEY DOCKET NO TKHR5060-D		
TITLE : Method for fabricating a thin film resistor					

U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-84)

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NOTICE OF ALLOWANCE MAILED		Assistant Examiner	CLAIMS ALLOWED	
			Total Claims	Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING	
Amount Due	Date Paid		Sheets Drwg.	Figs. Drwg.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner	
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